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PATENT
Customer No. 22,852
Attorney Docket No. 04329.2072-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Katsuki OHASHI et al.

Application No.: 09/870,702

Group Art Unit: 1756

Filed: June 1, 2001

Examiner: Mohamedulla, Saleha R.

For: METHOD FOR REPAIRING A
PHOTOMASK, METHOD FOR
INSPECTING A PHOTOMASK,
METHOD FOR
MANUFACTURING A
PHOTOMASK, AND METHOD
FOR MANUFACTURING A
SEMICONDUCTOR DEVICE

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed June 4, 2003, please amend the
above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks follow the amendment section of this paper.

Attachments to this amendment include references JP 2054101 and JP
2526986 with English Language Abstracts.

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